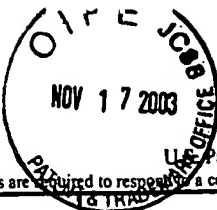


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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete if Known	
		Application Number	09/502,675
		Filing Date	September 3, 2002
		First Named Inventor	Shunpei YAMAZAKI
		Group Art Unit	2829
		Examiner Name	Evan T. PERT
		Attorney Docket Number	740756-2101
Sheet	1	of	2

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
EP 3P		6,144,082		Yamazaki et al.	11/07/2000	
		6,201,281	B1	Miyazaki et al.	03/13/2001	

FOREIGN PATENT DOCUMENTS								
Examiner Initials [*]	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

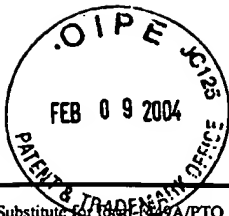
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INFORMATION DISCLOSURE STATEMENT				Applicants: Shunpei YAMAZAKI et al.			
				Filing Date: February 11, 2000		Group Art Unit: 2812	
OTHER DOCUMENT				(Including Author, Title, Date, Pertinent Pages, Etc.)			
Examiner Initial	<div style="position: relative;"> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px;"> O I P E J C B NOV 17 2003 PATENT AND TRADEMARK OFFICE </div> <div style="position: absolute; bottom: 0; left: 0; width: 100%; height: 100%; padding: 5px;"> Inventors: Shunpei YAMAZAKI et al., "Semiconductor Device and Fabrication Method Thereof" Filing Date: July 5, 2000, Specifications and Drawings for Application Serial No. 09/610,217 Inventors: Shunpei YAMAZAKI et al., "Semiconductor Device and Manufacturing Method Thereof" Filing Date: July 6, 2000, Specifications and Drawings for Application Serial No. 09/610,753 Inventor: Shunpei YAMAZAKI, "Semiconductor Device and Method of Fabricating the Same" Filing Date: December 23, 1999, Specifications and Drawings for Application Serial No. 09/471,359 Inventor: Shunpei YAMAZAKI, "Semiconductor Device and Fabrication Method Thereof" Filing Date: February 22, 2000, Specifications and Drawings for Application Serial No. 09/510,734 Inventor: Shunpei YAMAZAKI, "Method for Manufacturing an Electrooptical Device" Filing Date: March 22, 2000, Specifications and Drawings for Application Serial No. 09/533,175 Inventor: Shunpei YAMAZAKI, "Semiconductor Device and Method of Manufacturing the Same" Filing Date: February 7, 2000, Specifications and Drawings for Application Serial No. 09/498,646 </div> </div>						
Examiner <i>Evan Per t</i>		Date Considered <i>1/23/04</i>					
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		Application Number	09/502,675
		Filing Date	February 11, 2000
		First Named Inventor	Shunpei YAMAZAKI et al.
		Art Unit	2829
		Examiner Name	Evan T. Pert
Sheet	1	of	1
		Attorney Docket Number	740756-2101

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
EP		US-6,306,694	10-23-2001	YAMAZAKI et al.	
EP		US-6,355,942	03-12-2002	YAMAZAKI et al.	
EP		US-6,388,291	05-14-2002	ZHANG et al.	
EP		US-6,399,988	06-04-2002	YAMAZAKI	
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EP		US-6,524,895	02-25-2003	YAMAZAKI et al.	
EP		US-6,531,713	03-11-2003	YAMAZAKI	
EP		US-6,534,826	03-18-2003	YAMAZAKI	
EP		US-6,576,926	06-10-2003	YAMAZAKI et al.	
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FOREIGN PATENT DOCUMENTS						
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Examiner Signature	Evan Pert	Date Considered	1-23-04
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